

Lawrence Berkeley National Laboratory

Recent Work

Title

LOW-FREQUENCY PHOTON-ASSISTED TUNNELING IB SUPERCON-DUCTING TUNNEL
JUNCTIONS

Permalink

<https://escholarship.org/uc/item/3tk4w8s0>

Authors

Sweet, J.N.

Rochlin, G.I.

Publication Date

1970-05-01

c. 2

LOW-FREQUENCY PHOTON-ASSISTED TUNNELING IN
SUPERCONDUCTING TUNNEL JUNCTIONS

RECEIVED
LAWRENCE
RADIATION LABORATORY

JUN 1 5 1970

LIBRARY AND
DOCUMENTS SECTION

J. N. Sweet and G. I. Rochlin

May 1970

AEC Contract No. W-7405-eng-48

TWO-WEEK LOAN COPY

*This is a Library Circulating Copy
which may be borrowed for two weeks.
For a personal retention copy, call
Tech. Info. Division, Ext. 5545*

LAWRENCE RADIATION LABORATORY
UNIVERSITY of CALIFORNIA BERKELEY

UCRL-19619

37

DISCLAIMER

This document was prepared as an account of work sponsored by the United States Government. While this document is believed to contain correct information, neither the United States Government nor any agency thereof, nor the Regents of the University of California, nor any of their employees, makes any warranty, express or implied, or assumes any legal responsibility for the accuracy, completeness, or usefulness of any information, apparatus, product, or process disclosed, or represents that its use would not infringe privately owned rights. Reference herein to any specific commercial product, process, or service by its trade name, trademark, manufacturer, or otherwise, does not necessarily constitute or imply its endorsement, recommendation, or favoring by the United States Government or any agency thereof, or the Regents of the University of California. The views and opinions of authors expressed herein do not necessarily state or reflect those of the United States Government or any agency thereof or the Regents of the University of California.

Low-Frequency Photon-Assisted Tunneling in
Superconducting Tunnel Junctions

J. N. Sweet and G. I. Rochlin

Department of Physics, University of California
and
Inorganic Materials Research Division,
Lawrence Radiation Laboratory,
Berkeley, California 94720

ABSTRACT

The photon-assisted tunneling response of Sn-SnO-Pb and Sn-SnO-Sn superconducting junctions to a 3.9 GHz microwave field has been measured. The experimental response of the tunneling current to the rf field agrees very closely with the response predicted by the theory of Tien and Gordon. The predictions of the Cook and Everett theory do not fit the data well.

La réponse tunnel assisté par photons des jonctions Sn-SnO-Pb et Sn-SnO-sn à un champ de microondes à 3.9 GHz a été mesuré. La reponse expérimentale du courant tunnel au champ de haute fréquence est en très bon accord avec la réponse calculée à l'aide de la théorie de Tien et Gordon. Les prévisions de la théorie de Cook et Everett ne correspondaient pas bien aux résultats expérimentaux.

Microwave photon-assisted quasiparticle tunneling between two superconductors has been the subject of several recent experiments designed to investigate the range of validity of the simple Tien-Gordon¹ theory of this process and to advance or examine alternate, more complex theories. We have measured the photon-assisted tunneling response of Sn-SnO-Sn and Sn-SnO-Pb thin film junctions to a 3.9 GHz microwave electric field perpendicular to the junction plane, and compared the measured current-voltage (I-V) characteristics to the theories of both Tien and Gordon,¹ and Cook and Everett.² Excellent detailed agreement with the Tien-Gordon (TG) theory has been obtained for all junctions with normal state resistances greater than a few ohms. The Cook and Everett (CE) theory does not agree well with the experimental data, except at extremely low microwave (rf) power levels where both the CE and the TG theories converge to the same result.

In the TG theory the net effect of the microwave field of angular frequency ω is assumed to be the appearance of induced rf voltage, $V_{rf} \cos \omega t$, across the junction electrodes. The expression derived by TG for the dc current at a bias voltage V in the presence of a microwave field is

$$I_{TG}(V) = \sum_{n=-\infty}^{\infty} J_n^2(\alpha) I_0(V+n\hbar\omega/e), \quad (1)$$

where $\alpha = eV_{rf}/\hbar\omega$, $I_0(V)$ is the quasiparticle tunneling current in the absence of the rf field, and the J_n are ordinary Bessel functions of the first kind of order n .

Although TG derived Eq. (1) using somewhat heuristic arguments about modulation of the densities of states, the same result can in fact be derived from more general theory.³⁻⁶ The TG result also reduces to the correct classical expression for the average (dc) current,

$$I_{RF}(V) = \frac{\omega}{2\pi} \int_0^{2\pi/\omega} I_0(V+V_{rf} \cos \omega t) dt, \quad (2)$$

in the limit $\hbar\omega \rightarrow 0$. If the integrand in (2) is expanded in a Taylor series about V and integrated term by term, the resultant series is exactly the same as that derived by Goldstein, Abeles, and Cohen⁷ from Eq. (1) in the limit $\hbar\omega \rightarrow 0$.

In an attempt to explain their 36 GHz photon-assisted tunneling measurements, Cook and Everett² proposed a modified theoretical model based on modulation of the densities of states in both the superconducting films. Their result for the current in the presence of a microwave electric field is given by

$$I_{CE}(V) = \sum_{n,m=-\infty}^{\infty} J_m^2(\alpha) J_n^2(\alpha) I_0[V+(n-m)\hbar\omega/e]. \quad (3)$$

After some manipulation, Eq. (3) may be rewritten in the form,

$$\begin{aligned} I_{CE}(V) = & J_0^2(\alpha) I_{TG}(V) + 2 \sum_{m=1}^{\infty} J_m^4(\alpha) I_0(V) \\ & + \sum_{m,n=1}^{\infty} J_m^2(\alpha) [J_{m+n}^2(\alpha) + J_{m-n}^2(\alpha)] \\ & \times [I_0(V+n\hbar\omega/e) + I_0(V-n\hbar\omega/e)]. \end{aligned} \quad (4)$$

In the limit $\alpha \rightarrow 0$, $J_0^2(\alpha) \rightarrow 1$ while all other J_n approach zero, and hence $I_{CE}(V) \rightarrow I_{TG}(V)$. As α becomes appreciably greater than 1, the difference between I_{CE} and I_{TG} becomes quite large, indicating that I_{CE} does not reduce to the correct classical limit when $\hbar\omega \rightarrow 0$.

In our experiments, conventional crossed-strip tunnel junctions were placed on the sidewall of a TE₁₀₁ rectangular resonant cavity at a point where E_{rf} was perpendicular to the plane of the junctions and $H_{rf} \approx 0$. All junctions tested had areas of $(0.16 \times 0.16) \text{ mm}^2$, with metallic film thicknesses between 2000 Å and 6000 Å. The Sn-SnO-Sn junctions had normal state resistances of 2 - 7 Ω while Sn-SnO-Pb junctions were in the range 20 - 130 Ω. All junc-

tions with normal state resistances less than 30Ω had appreciable dc Josephson currents, which were quenched with a small magnetic field during our measurements. A comparison of typical experimental results for a high resistance Sn-SnO-Pb junction with theory is shown in Fig. 1. The curves marked I_{TG} and I_{CE} were calculated from Eqs. (1) and (3) respectively, using the measured $I_0(V)$. The value of α was deduced by fitting an experimental I-V curve to a theoretical TG curve at a high microwave power level (in this case, one corresponding to $\alpha=60.2$). α was then scaled as the square root of the microwave power incident on the cavity. The curve marked I_{BCS} is the bare current predicted by the BCS constant Δ model with $\Delta_{Pb} + \Delta_{Sn} = 1.98$ meV at $1.1^\circ K$. Since $\hbar\omega/e = 16 \mu V$, while the width of the current step in $I_0(V)$ at $\Delta_{Pb} + \Delta_{Sn}$ is $\approx 175 \mu V$, we can not resolve individual microwave induced steps^{2,7} in the I-V characteristics at voltages $V_n = \Delta_{Pb} + \Delta_{Sn} \pm n\hbar\omega/e$. These steps will begin to appear when the angular frequency satisfies the condition $\hbar\omega/e \geq 175 \mu V$, corresponding to a frequency $\nu \geq 40$ GHz. In Fig. 2, the current deviation, $\Delta I = I(V) - I_0(V)$, is plotted at three different microwave power levels for the junction whose $I_0(V)$ characteristic is shown in Fig. 1. The close agreement between the experimental data and the TG theory is clear.

In Fig. 3, $\Delta I(V)$ is shown for a 6.35Ω Sn-SnO-Sn junction at a relatively low microwave power level corresponding to $\alpha=1.8$. Even at this low value of α , the differences between the CE and TG theories are quite pronounced. It can also be seen that $I_{RF}(V)$ is very close to $I_{TG}(V)$ even at this low value of α . Numerical calculations indicate that I_{TG} and I_{RF} are approximately equal when $\alpha \geq 10$ for 4 GHz microwaves.

In view of the detailed agreement between the predictions of the TG theory and the experimental data for low-frequency photon-assisted tunneling, it would

appear that recent attempts^{2,7} to explain the results of higher frequency tunneling experiments with Eq. (3) are incorrect. An alternate explanation for the deviation of experimental results from Eq. (1) at high microwave frequencies has recently been proposed by Hamilton and Shapiro⁸ to explain their experimental data at 70 GHz. Their theory uses Eq. (1) but takes into account the transverse spatial variation of the rf voltage across the junction. Since the free space wavelength, λ_0 , of the electromagnetic radiation is reduced by a factor of approximately 20 in the oxide barrier,⁹ this variation is important only at frequencies where $\lambda_0/20 \sim$ junction width. At 4 GHz, $\lambda_0/20 \approx 3.7$ mm, which is much larger than the junction width used in our experiments. Thus, the basic TG result, Eq. (1), can be expected to provide a correct theoretical description of our experimental data, while for frequencies ≥ 40 GHz, $\lambda_0/20 \leq 0.37$ mm and spatial variation would have to be taken into account.

To summarize, we have observed excellent agreement between our low-frequency photon-assisted tunneling observations and the basic theory of Tien and Gordon over a wide range of microwave power levels, while the agreement with the theory of Cook and Everett has been found to be quite poor. We therefore conclude that the TG formula does in fact provide the correct description of the basic photon-assisted tunneling process, and that deviations from the TG formula at high frequencies are most probably attributable to spatial variation of the rf voltage induced in the junction.

ACKNOWLEDGEMENTS

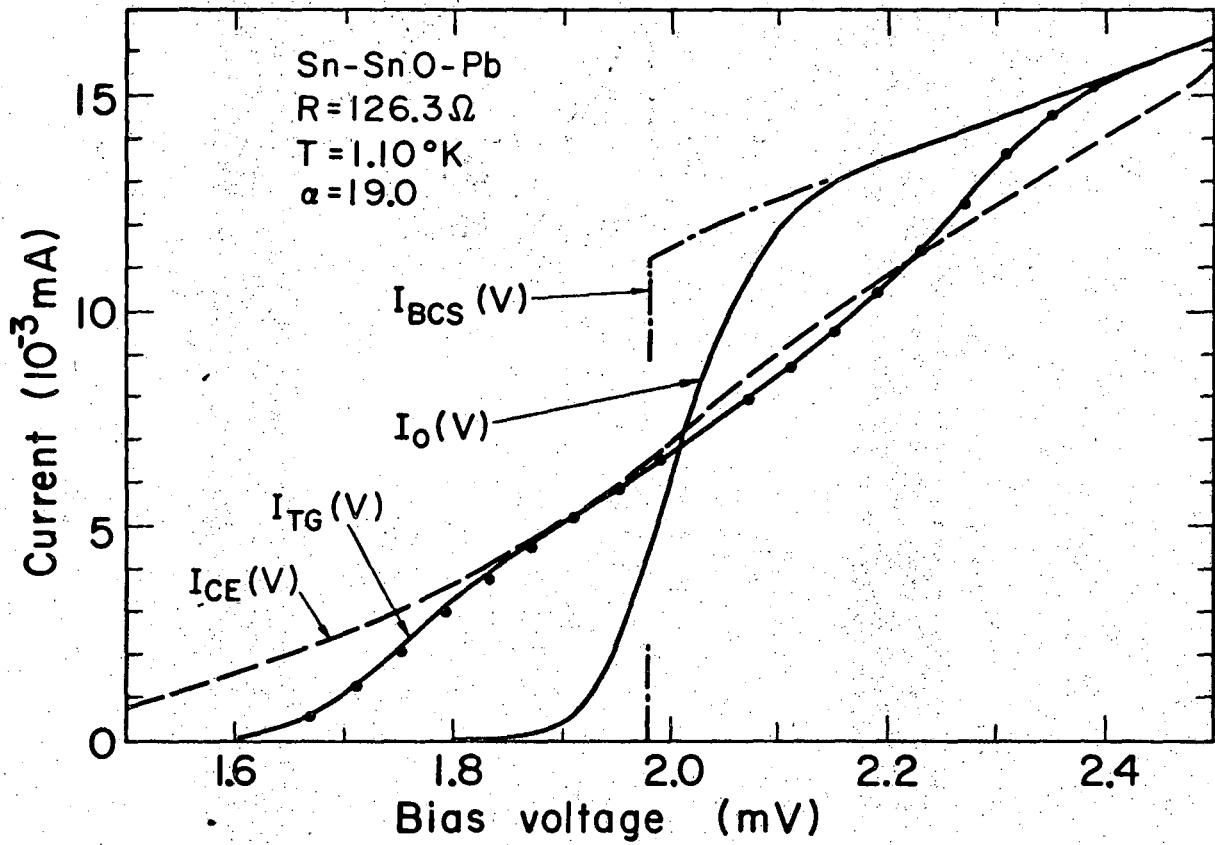
This work was performed under the auspices of the U. S. Atomic Energy Commission.

REFERENCES

1. TIEN, P. K. and GORDON, J. P., Phys. Rev. 129, 647 (1963).
2. COOK, C. F. and EVERETT, G. E., Phys. Rev. 159, 374 (1967).
3. RIEDEL, E., Z. Naturforsch, 19A, 1634 (1964).
4. WERTHAMER, N. R., Phys. Rev. 147, 235 (1967).
5. BÜTTNER, H. and GERLACH, E., Phys. Letters 27A, 266 (1968).
6. SWEET, J. N. and ROCHLIN, G. I., Phys. Rev. (Aug. 1, 1970).
7. TELLER, S. and KOFOED, B., Solid State Comm. 8, 235 (1970).
8. HAMILTON, C. and SHAPIRO, S., Bull. Am. Phys. Soc. 15, 320 (1970).
9. LANGENBERG, D. N., SCALAPINO, D. J., TAYLOR, B. N., Proc. IEEE 54, 560 (1966).

FIGURE CAPTIONS

- Fig. 1. Typical I-V characteristics for a Sn-SnO-Pb junction at voltages near $\Delta_{\text{Pb}} + \Delta_{\text{Sn}}$. $I_0(V)$ is the measured bare current. $I_{\text{TG}}(V)$ was derived from Eq. (1) using $\alpha=19$, and $I_{\text{CE}}(V)$ was derived from Eq. (3) for the same value of α . The points are experimental. $I_{\text{BCS}}(V)$ is the current predicted by the BCS constant Δ model.
- Fig. 2. $\Delta I(V, \alpha) = I(V, \alpha) - I_0(V)$ derived from measured I-V graphs for the junction of Fig. 1. P_D is the average power dissipated in the microwave cavity and V_0 is an arbitrary voltage near $\Delta_{\text{Pb}} + \Delta_{\text{Sn}}$ chosen for convenience in data reduction. The α values were scaled as $(P_D)^{1/2}$ after fitting a theoretical $\Delta I_{\text{TG}}(V)$ to measured data at $P_D = 19.5$ mW (not shown).
- Fig. 3. $\Delta I(V, \alpha)$ for a 6.35Ω Sn-SnO-Sn junction at $\alpha = 1.8$. $\Delta I_{\text{RF}}(V)$ has been calculated from Eq. (2), using $V_{\text{rf}} = 1.8 \hbar\omega/e$. The points are experimental values.



XBL704-2723

Fig. 1

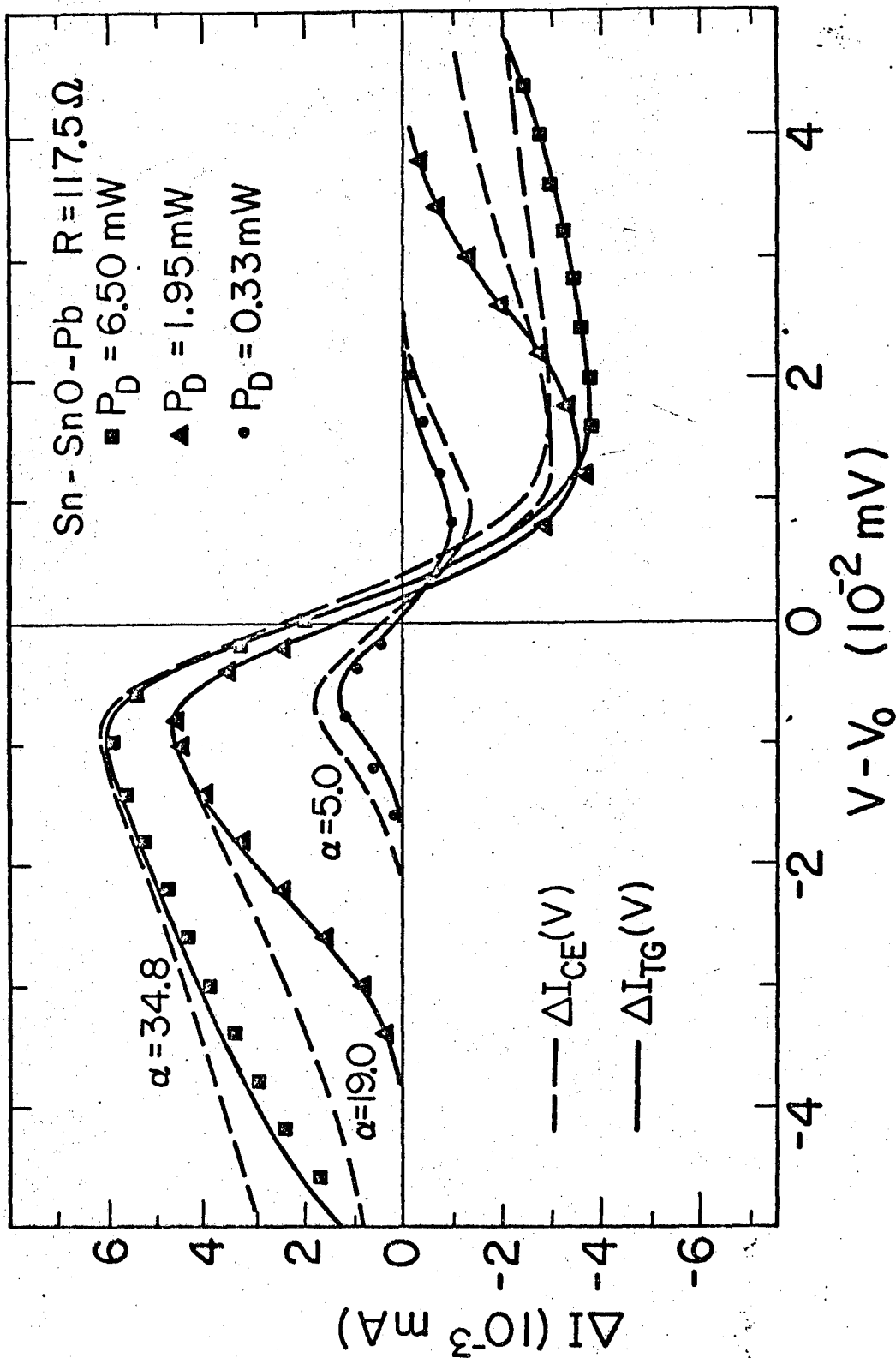


Fig. 2 XBL704-2724

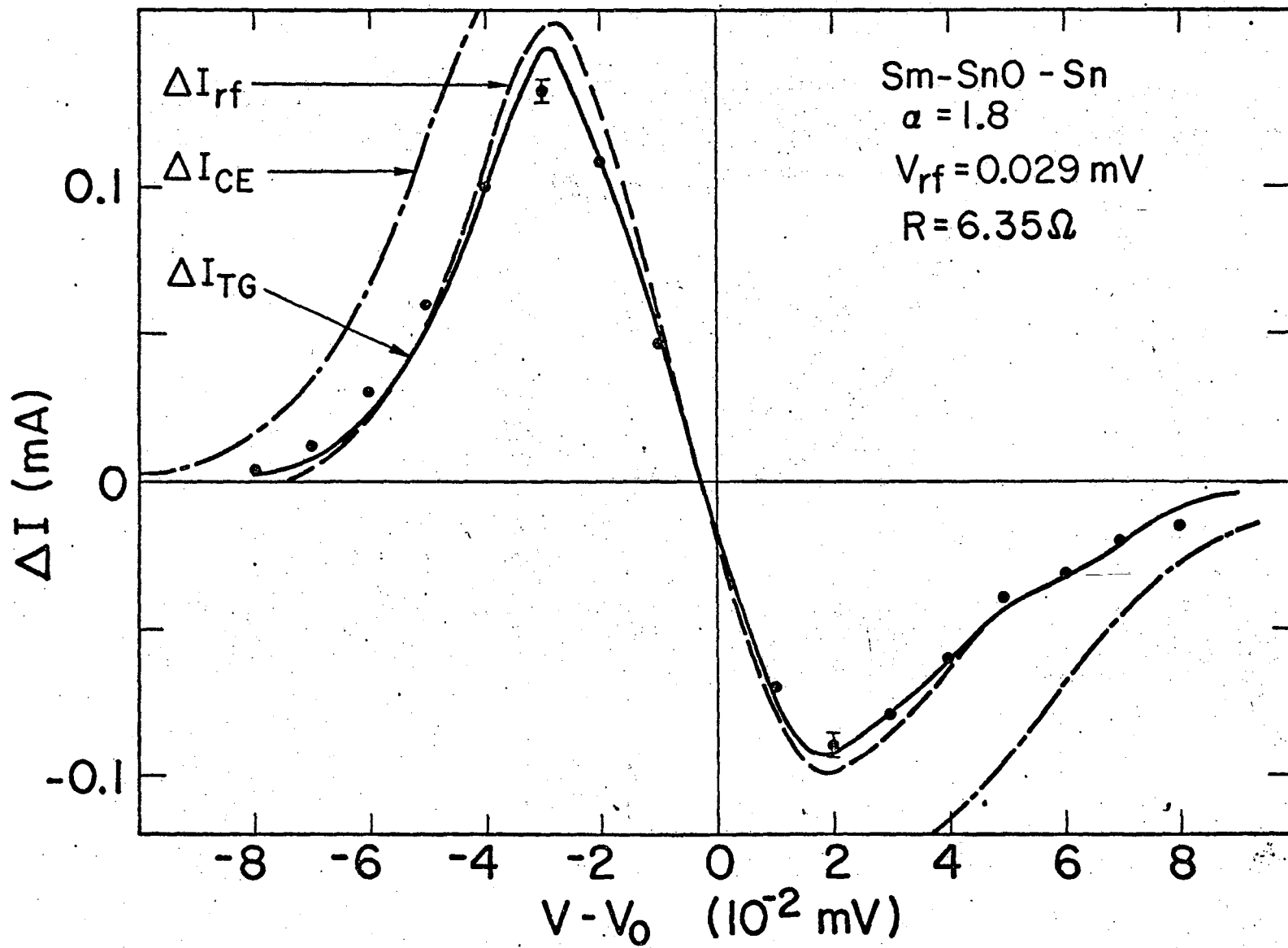


Fig. 3

XBL704-2725

LEGAL NOTICE

This report was prepared as an account of Government sponsored work. Neither the United States, nor the Commission, nor any person acting on behalf of the Commission:

- A. Makes any warranty or representation, expressed or implied, with respect to the accuracy, completeness, or usefulness of the information contained in this report, or that the use of any information, apparatus, method, or process disclosed in this report may not infringe privately owned rights; or*
- B. Assumes any liabilities with respect to the use of, or for damages resulting from the use of any information, apparatus, method, or process disclosed in this report.*

As used in the above, "person acting on behalf of the Commission" includes any employee or contractor of the Commission, or employee of such contractor, to the extent that such employee or contractor of the Commission, or employee of such contractor prepares, disseminates, or provides access to, any information pursuant to his employment or contract with the Commission, or his employment with such contractor.

TECHNICAL INFORMATION DIVISION
LAWRENCE RADIATION LABORATORY
UNIVERSITY OF CALIFORNIA
BERKELEY, CALIFORNIA 94720